

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application

Inventor(s): Tue Nguyen, Tai Dung Nguyen  
Appln. No.: 10/790,652  
Confirm. No.: 9765  
Filed: March 1, 2004  
Title: NANOLAYER THICK FILM PROCESSING  
SYSTEM AND METHOD

**PATENT APPLICATION**

Art Unit: 2812  
Examiner: Geyer, Scott B.

**Customer No. 23910**

**RESPONSE TO OFFICE ACTION**

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 1, 2006, please amend the above-identified application as followed:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.